

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/797,591  
Filing Date: March 10, 2004  
Applicant: Toshimitsu Hirai et al.  
Group Art Unit: 1792  
Examiner: NGAMPA, Briget P  
Title: PATTERN FORMING METHOD PATTERN FORMING  
APPARATUS, METHOD OF MANUFACTURING DEVICE ...  
Attorney Docket: 9319S-000727

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action mailed January 15, 2008, please amend the application as follows and consider the remarks set forth below.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 7 of this paper.